



Docket No.: 1572.1251

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Sang-in LEE Group Art Unit: 2857

Serial No. 10/791,808 Examiner: Patrick J. Assouad

Filed: March 4, 2004

For: PERFORMANCE MEASUREMENT SYSTEM

COMMUNICATION TO EXAMINER

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

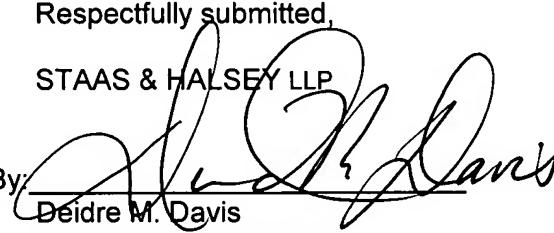
A Notice of Allowance was mailed on October 17, 2005 for the subject application. An Information Disclosure Statement was filed on November 30, 2005. A copy of the USPTO-stamped filing receipt along with the PTO-1449 Form is attached hereto. The Applicant respectfully requests that the Examiner acknowledge the references cited on the PTO-1449 Form.

Date: 1/17/2006

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Respectfully submitted,

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INFORMATION DISCLOSURE STATEMENT ALONG WITH PTO-1449 (3 REFERENCES) AND CHECK
FOR \$180.00

APPLICANT(S): Sang-In LEE

SERIAL NO: 10/791,808

CONFIRMATION NO. 5234

TITLE: PERFORMANCE MEASUREMENT SYSTEM

FILING DATE: March 4, 2004

DOCKET NO: 1572.1251/GMG/DMD:jla

DUE DATE: December 27, 2005



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Sheet 1 of 1

FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTORNEY DOCKET NO.

1572.1251

APPLICATION NO.

10/791,808

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

FIRST NAMED INVENTOR

Sang-In LEE

FILING DATE

March 4, 2004

GROUP ART UNIT

2857

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	TRANSLATION YES NO	ABSTRACT
	AG	2002-208956	07/26/2002	Japan		X
	AH	2002-008179	01/11/2002	Japan		X
	AI					
	AJ					
	AK					
	AL					

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

TRANSLATION YES NO

AM	Korean Intellectual Property Office Notice of Official Action for corresponding Korean Patent Application No. 10-2003-0049307			X	
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EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.